

Attorney Docket: 081468-0354685
Client Reference: P-1775.010-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:
MODDERMAN, ET AL.

Confirmation Number: 8421

Application No.: **10/583,985**

Group Art Unit: 2886

Filed: June 4, 2007

Examiner: FAJOOHI, Tara S.

Title: LITHOGRAPHIC APPARATUS, METHOD OF EXPOSING A SUBSTRATE,
METHOD OF MEASUREMENT, DEVICE MANUFACTURING METHOD, AND DEVICE
MANUFACTURED THEREBY

REPLY TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated August 21, 2009, Applicants hereby elects the invention of Group I, claims 1-23 and 37-46, drawn to a lithographic apparatus and method to measure a plurality of heights of a substrate using a first and second sensor. This election is made without traverse.

Prompt examination and favorable consideration on the merits are respectfully requested.

Please charge any fees associated with the submission of this paper to Deposit Account Number 033975. The Commissioner for Patents is also authorized to credit any over payments to the above-referenced Deposit Account.

Respectfully submitted,

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